Wearable Strain Sensor Using Light Transmittance Change of Carbon Nanotube Embedded Elastomer with Microcrack
Wearable Strain Sensor Using Light Transmittance Change of Carbon Nanotube Embedded Elastomer with Microcrack

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KEYWORDS

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ABSTRACT

A number of flexible and stretchable strain sensors based on piezoresistive and capacitive principles have been recently developed. However, piezoresistive sensors suffer from poor long-term stability and considerable hysteresis of signals. On the other hand, capacitive sensors exhibit limited sensitivity and strong electromagnetic interference from neighboring environment. In order to resolve these problems, a novel stretchable strain sensor based on the modulation of optical transmittance of carbon nanotube (CNT)-embedded Ecoflex is introduced in this paper. Within the film of multi-walled carbon nanotubes (MWCNTs) embedded in the Ecoflex substrate, the microcracks are propagated under tensile strain, changing the optical transmittance of the film. The
proposed sensor exhibits a good stretchability (ε~400 %), high linearity (R²> 0.98) in the strain range of ε=0-100 %, excellent stability, high sensitivity (gauge factor ~ 30), and small hysteresis (~1.8 %). The sensor was utilized to detect the bending of the finger and wrist for the control of robot arm. Furthermore, the applications of this sensor to the real-time posture monitoring of the neck and to the detection of subtle human motions were demonstrated.

**INTRODUCTION**

Recently, stretchable and flexible strain sensors are considered as very useful components for the wearable healthcare and human-machine interface systems. For human motion detection, mechanical flexibility, linearity, sensitivity, stability, and dynamic range of the sensors should be sufficient.¹⁻⁷ In order to satisfy these requirements, various stretchable strain sensors based on nanomaterial-polymer composite have been developed. For example, polymer composites with silver nanowires,⁸⁻¹⁰ silver nanoparticles,¹¹,¹² graphene,¹³,¹⁴ and carbon nanotubes (CNTs)¹⁵⁻²⁰ have been utilized
as the functional nanomaterials for the stretchable strain sensors. Especially, CNT is widely used as a functional nanomaterial for the strain sensors because of its good mechanical, electrical characteristics, and thermal stability.

Most research on the strain sensors with CNTs as a functional nanomaterial have been based on the piezoresistive or piezocapacitive transduction mechanisms by the external strain. Previously, dual layer structure composed of CNT film and elastomer substrate as well as CNT-elastomer mixture composite structure have been used as strain sensing materials. Among them, some piezoresistive strain sensor has shown high stretchability (ε~500 %), high sensitivity, and easy integration for practical applications. For piezoresistive sensors, sensor performances can be improved by modulating the characteristics of the elastomer composite with single-walled CNTs (SWCNTs) or multi-walled CNTs (MWCNTs). More recently, applying core-shell structure using CNT, improvement of high stretchability and high sensitivity were suggested. With these efforts, some piezoresistive strain sensors have shown a high gauge factor (GF>20), but they have suffered from poor linearity in high strain region (ε~100 %). Moreover, poor
stability and high sensitivity to the temperature and humidity have been common problems of the piezoresistive sensors. On the other hand, piezocapacitive strain sensors based on CNT-elastomer mixture composite have shown better stability, lower hysteresis, and high stretchability ($\varepsilon \sim 500\%$).\textsuperscript{22} However, the piezocapacitive type strain sensors have gauge factors relatively lower than the piezoresistive type sensors and are highly influenced by the surrounding conductive objects because of the electromagnetic interference.

The optical type strain sensor can be a good alternative to resolve the abovementioned limitations of piezocapacitive and piezoresistive strain sensors, because they are less affected by the environmental disturbances. Recently, an optical type strain sensor based on the change of optical transmittance of titanium oxide ($\text{TiO}_2$) – Ecoflex composite have been introduced.\textsuperscript{27} The sensor was composed of a light detector, a light source, and $\text{TiO}_2$-Ecoflex composite between them, showing a high stretchability ($\varepsilon \sim 500\%$) and a moderate transmittance change (30% change of transmittance for $\varepsilon \sim 500\%$). However, this sensor exhibited a low gauge factor (~3.1), and critical sensing performances such as dynamic
response, limit of detection, hysteresis, strain rate dependence, and reproducibility of the sensor were not presented in this article. Furthermore, only a limited application such as finger bending motion detection was demonstrated.

In this paper, we introduce an optical type stretchable strain sensor based on the change of optical transmittance of the CNT-embedded Ecoflex film. In order to achieve a large dynamic range of the sensor, we chose the Ecoflex as an elastomeric substrate with low Young’s modulus (E~125kPa), good mechanical durability, flexibility, and attachability on the human skin. MWCNTs were spray coated and embedded into the Ecoflex substrate, and the microcrack propagation in this MWCNT film led to the optical transmittance change. We evaluated critical sensing performances of the developed strain sensor such as sensitivity, linearity, dynamic characteristics, hysteresis, stability, and reproducibility. It showed good stretchability (ε~400 %), high linearity (R²>0.98), excellent stability, high sensitivity (GF~30), and small hysteresis (~1.8%). The sensor responses were observed to be independent on the intensity of the light source and strain rate. The sensor was utilized to detect the bending of the finger and wrist for the control of robot arm.
Furthermore, the applications of this sensor to the real-time monitoring of the neck posture, carotid pulse, and face expression were performed.

EXPERIMENTAL SECTION

Fabrication of CNT-embedded Ecoflex Thin Film, Pristine Ecoflex, and CNT-Ecoflex Mixture Composite

First, CNTs (Hanhwa Chemical, Republic of Korea) were mixed with isopropyl alcohol (0.025 wt%) and spray-coated on the donor substrate (Poly(ethyl benzene-1,4-dicarboxylate), PET petri dish). The coating density was controlled by measuring the sheet resistance of deposited CNT film. Ecoflex prepolymer (Smooth-On, Inc., USA) was prepared by mixing with a curing agent at a weight ratio of 1:1. It was first poured on the donor substrate that was already coated with CNTs, and then was cured at room temperature (25°C) for 3hrs. As a result, the CNTs were embedded into the Ecoflex substrate. After curing, CNT-embedded Ecoflex was detached from the donor substrate (Figure S1).
Pristine Ecoflex and CNT-Ecoflex mixture composite were used to compare the performance of the strain sensor. In order to make pristine Ecoflex, prepolymer mixture with a curing agent (1:1 weight ratio) was poured on the donor substrate (PET petri dish), and then cured at room temperature (25°C) for 3 hrs. In order to make CNT-Ecoflex mixture composite, CNTs were added on the Ecoflex prepolymer mixed with curing agent at a weight ratio of 1:1. CNTs and Ecoflex were mixed using a planetary mixer for 2 mins. The amount of CNT ratio is 0.52wt% which is same amount of CNT density with sheet resistance 78.9Ω/□ of CNT-embedded Ecoflex. After pouring on the donor substrate (PET petri dish), bubbles were removed using a vacuum chamber. After curing at room temperature for 3 hrs, the CNT-Ecoflex mixture was removed from the donor substrate.

**Measurement System**

As a light source to characterize the sensor performance, solar illuminator (LAX-C100 Xenon light source, Asahi Spectra Co., Ltd., Inc., Japan) with a visible range (λ=400-800 nm) was employed (Figure S2). The intensity of the light transmitted through the
CNT-embedded Ecoflex thin film was measured using a photodiode power sensor (S120C, Thorlabs, Inc., USA) with a USB power and energy interface (PM100USB, Thorlabs, Inc., USA). The tensile strain was applied by a customized linear stage. The optical characteristics of CNT-embedded Ecoflex thin film was examined using a UV-VIS Spectrometer (Lambda 650, Perkin Elmer, Inc., USA). Before characterization, fabricated CNT-embedded Ecoflex thin film was tested under the conditions of about 10% initial-strain after 200% pre-strain.

In order to evaluate the sensor performance in harsh environmental conditions, especially in different humidity conditions, the whole space was sealed using the polyvinyl plastic to maintain particular relative humidity by humidifier. The humidity of the space was measured by commercial humidity sensor (A13T, UNI-TREND TECHNOLOGY CO., LTD. China).

For high temperature experiment, CNT-embedded Ecoflex was attached to a slide glass and hung within a convection oven for 72 hrs. The length of the CNT-embedded Ecoflex thin film was measured after 1 hr, 2 hrs, 3 hrs, 5 hrs, 12 hrs, 24 hrs and 72 hrs.
later. The load (weight= 50 g and 200 g) was hung at the edge of the Ecoflex and the fine pin was fixed for the length measurement with a metal ruler.

-Thermal characteristics of Ecoflex

The thermal characteristics of Ecoflex 0030 was examined using differential scanning calorimetry (DSC, 214 Polyma, NETZSCH, Germany) and thermogravimetric analysis (TGA, TG209 F1 Libra, NETZSCH, Germany). For each analysis, the Ecoflex 0030 agents A and B were mixed at 1:1 weight ratio and cured at T=100°C for 3 hrs. DSC analysis was conducted using a sample mass of 8.301 mg at the temperature from 20°C to 200°C in a N\textsubscript{2} environment. Thermogravimetric analysis was conducted using a sample mass of 7.661 mg at temperature from 30°C to 700°C in a N\textsubscript{2} environment.

Image Analysis

The photographs taken by the CCD camera were converted into 8 bit gray tone images, and each image was set to the same intensity to calculate the area of the bright part that increased with microcrack opening by applied tensile strain (Figure S3).
**Strain sensor package for human motion detection**

A light emitting diode (LED) and photodiode (i.e. photodetector) were integrated with the CNT-embedded Ecoflex thin film for sensor packaging (Figure S4). A chip LED (5550 SMD LED, peak wavelength $\lambda=520$ nm, ITSWELL, Inc., Republic of Korea) and a surface mount device type photodiode (TEMD6010FX01, Vishay, Inc., USA) embedded in the Ecoflex film were attached on the upper and lower sides of CNT-embedded Ecoflex thin film, respectively. LED and photodiode were embedded in the Ecoflex by placing them in a 3D printed thermoplastic polyurethane (TPU) mold with a dimension of 50 mm $\times$ 15 mm $\times$ 2 mm, followed by pouring Ecoflex prepolymer and curing at 60°C. Each side of the LED and photodiode embedded Ecoflex was attached with the CNT-embedded Ecoflex thin film with a silicone adhesive (Sil Poxy, Smooth-On, Inc., USA). The total thickness of the strain sensor package was less than 5 mm. A single-axial strain sensor package was utilized for the detection of finger and wrist motions, neck pulses, uvula swallowing, and face expression. Tri-axial strain sensor package for neck posture monitoring was also fabricated by the same method. When the direction parallel
to the cervical vertebral is assumed to be 0 degree, an array of three strain sensors with
an angle of 0°, -15°, and +15° for each sensor was fabricated.

**Measurement system of human motion detection**

The LED of strain sensor package was connected with a power supply with a bias
voltage of 3V. For a single-axial strain sensor package, the photodiode was connected
with a source meter (Keithley 2400, Tektronix, Inc., USA) that was controlled by
LABVIEW program (National Instruments, USA) to measure the real-time current in a
reverse bias mode (bias voltage=-0.1 V). For each human motion detection, each end of
the strain sensor package was attached on the skin. Tri-axial strain sensor package for
the neck posture monitoring was also fixed with a medical double-sided tape. In
particular, the root of the sensor was attached on the location of the cervical vertebral.

For a Tri-axial strain sensor package, each photodiode was connected with an
operating amplifier to convert the current signal to voltage signal. The voltage output
was measured by Arduino UNO, which can measure more than 3 channels
simultaneously in real-time.
Control of Robot Arm by Finger and Wrist Motion Detection

For controlling the robot arm using the designed sensor, a source meter and photodiode were replaced with Arduino UNO REV3 and (Cadmium sulfide) CdS cell (GL3526 CdS, Cosocomy, Inc., China), respectively, to simplify the data acquisition and motion control of robot arm. A voltage divider circuit with a serial connection of a variable resistor (i.e. CdS cell) and a fixed resistor, and a constant 5V voltage supplied from Arduino was utilized. The Arduino board was used to provide power (bias voltage=5 V) to the LED and to read the voltage change by the light intensity change from the CdS cell. Robot gripper and wrist motor were connected with the Arduino digital control pin for motion control and a 9V battery was used for the power supply. In the Arduino code, the human finger and wrist movements were converted to the motor control values of robot gripper and the robot wrist, respectively.

RESULT AND DISCUSSION
Figure 1a describes the principle of the proposed sensor. The external strain applied to the Ecoflex transfers to the embedded CNTs, generating microcracks that are propagated in proportion to the applied strain. A light source and a photodetector are installed on the upper and lower sides of the CNT-embedded Ecoflex thin film, respectively. Before the microcrack generation, the light transmission through the CNT-embedded Ecoflex thin film is very low because of the absorbance and scattering of the incident light by the embedded CNTs. When the microcrack is generated by the applied strain, light can pass through the microcrack opening, and therefore the optical transmittance of the CNT-embedded Ecoflex thin film increases as shown in Figure 1b. Initially on a zero strain, the background letter was completely blocked by the CNT-embedded Ecoflex thin film. As the external strain is increased, the optical transmittance of CNT-embedded Ecoflex thin film is raised and thereby the background letter gradually appears. Figure 1c displays the images of the microcrack generation and propagation corresponding to the external strain that are captured by a CCD camera. In this figure, the bright side of the image is Ecoflex that transmits the incident light. As the applied strain is increased, more microcracks are generated and further propagated, which opens the path for the light transmission.
Figure 1. Principle and mechanism of the CNT-embedded Ecoflex thin film based strain sensor: (a) schematic of the sensor based on the optical transmittance change of the CNT-embedded Ecoflex thin film due to the microcrack opening of CNT network and the SEM image of spray coated CNTs, (b) photographs of the optical transmittance change of CNT-embedded Ecoflex thin film by the applied tensile strain, (c) CCD camera image
of the microcrack generation and propagation in the CNT-embedded Ecoflex thin film under increasing tensile strain.

The optical transmittance change of the CNT-embedded Ecoflex thin film by the applied strain (ε=0-100 %) is depicted in Figure 2a. The output response is defined as $\Delta I / I_0$, in which $I_0$ and $\Delta I$ represent the initial light intensity and the change of light intensity through the CNT-embedded Ecoflex thin film, respectively. The transmittance is the effectiveness of light transmission, which is defined as the ratio of the light intensity passing through the medium to the original intensity of the incident light. From this relationship, the ratio of light intensity change to the initial light intensity represents the relative transmittance change of the medium. The responses in loading and unloading cycles show negligible hysteresis. Here, the hysteresis is defined by the ratio of the midpoint gap between the loading and unloading curves to the gap between the minimum and maximum output values. It is shown that almost complete recovery is achieved with an error of 1.9 % and the hysteresis is as low as 1.8 % for three loading cycles. Also, the sensor response to the applied strain can be approximated as a linear function with $R^2 = 0.997$. As mentioned
above, our proposed sensors were first pre-strained by 200 % after they were fabricated.

By this pre-stretching process, most of the initial cracks were generated before the performance characterization and application of the sensors. Therefore, crack opening and closure occur from initially formed cracks where tensile stress is concentrated. This enables quick and complete recovery of crack dimensions. In case of piezoresistive sensors based on the nanomaterial-elastomer composites, the recovery of ohmic contact between nanomaterial fillers should take place when strain is released, which results in the hysteresis\(^8\). In contrast, in our sensor, as long as the crack dimensions are recovered, the optical transmittance is immediately recovered. We presume that this would be the reason for the negligible hysteresis of our sensor.

Figure 2b compares the responses of CNT-embedded Ecoflex thin film, pristine Ecoflex, and CNT - Ecoflex mixture composite to the applied tensile strain in the range of \(\varepsilon=0\%-100\%\). The gauge factors of pristine Ecoflex and CNT - Ecoflex mixture composite are GF=0.07 and GF=0.85, respectively. In the case of CNT-Ecoflex mixture composite, it has been reported that their stretching results in the rearrangement of the CNT filler inside
elastomer matrix\textsuperscript{28,29}. Here, the crack opening does not occur but only the rearrangement of CNT happens, thereby no significant change of optical transmittance is generated. On the other hand, CNT-embedded Ecoflex thin film shows much larger gauge factor (GF=31.66). This phenomenon can be attributed to the large transmittance change caused by the amount of light passing through the microcracks generated by the strain, which is explained in detail later.

There are some factors that affect the response of the proposed sensor. As mentioned above, the response of the sensor is defined by the ratio of the light intensity change to the initial light intensity that transmit through the CNT-embedded Ecoflex thin film. The light intensity is determined by the optical transmittance of the film. Therefore, the initial light transmittance affects the sensitivity of the sensor. Initial CNT coating density and the pre-strain on the CNT-embedded Ecoflex thin film are dominant factors to determine the initial light transmittance. The initial CNT coating density is indirectly evaluated by the sheet resistance of the spray coated CNT random network. The sheet resistance decreases when the density of the CNT film increases (Figure S5a). Due to
this reason, the initial light transmittance decreases when the sheet resistance is lower (Figure S5b). As a result, the gauge factor of the sensor increases from 5 to 175 when the sheet resistance was decreased from 650 $\Omega/\square$ to 40$\Omega/\square$ (Figure S5c). However, when the sheet resistance was smaller than 40$\Omega/\square$, spray coated CNT film did not get fully embedded in the Ecoflex substrate, which causes the delamination of CNTs from the Ecoflex (Figure S5d).

In addition, even if the density of the CNT film is identical, the sensor response also depends on the pre-strain and initial strain of the CNT-embedded Ecoflex thin film. As shown in Figure S6a, when 50 % pre-strain was applied and a little microcracks were formed, 100 % strain loading-unloading showed high hysteresis (4.6 %) due to newly formed micro-cracks. On the other hand, when 200 % pre-strain was applied, much smaller hysteresis (1.5 %) was observed. This is because most crack opening occurs from the initially formed cracks by 200 % pre-strain and new cracks are rarely generated in other locations. For the sensor characterization and applications, we have applied small positive initial strains in order to obtain stable sensor signals. Here, the degree of
the initial strain is defined as $\varepsilon_i = (L_i - L_0)/L_0$ and applied strain is defined as $\varepsilon = (L - L_i)/L_i$, in which $L_0$ and $L_i$ represent the original length of CNT-embedded Ecoflex film and the length when it was fixed on the linear stage, respectively. As the initial strain increases, initial light transmittance through the CNT-embedded Ecoflex film increases and thus GF decreases (Figure S6b and c). Figure 2c shows the sensor response in the loading and unloading cycles for the strain larger than $\varepsilon = 100\%$. Using Ecoflex as a base material, the dynamic range is as wide as $\varepsilon \approx 400\%$. The hysteresis of the sensor is 1.8\% for the strain range of $\varepsilon = 0$-100\% whereas 7.6\% for the strain range of $\varepsilon = 0$-400\% (Table S1). Also, the linearity of the sensor worsens when the strain range is increased. This can be explained by the mechanism of light transmittance change through the film. When the initial strain is applied within the area of the photodetector, the light transmittance changes as a result of the formation of microcracks between the CNTs. However, if the stretching exceeds a certain range, the amount of additional microcrack formation decreases and the increasing rate of light transmittance is reduced. The reason of this phenomenon is due to large young's modulus difference between MWCNT (a few GPa$^{30}$) and Ecoflex ($\sim125$kPa). By initial stretching, cracks are
randomly generated and propagated in the MWCNT film. If more strain is applied, due
to the large Young's modulus difference between Ecoflex and MWCNT film, no new
cracks are generated and stretching occurs only in the Ecoflex region. The crack
opening can be simply modeled as shown in Figure S7 (a). Here, $L_A$ and $L_B$ represent
the lengths of transparent (i.e. Ecoflex) and opaque (i.e. MWCNT) regions, respectively.
The optical transmittance in the model could be represented as $L_A/(L_A+L_B)$. As more
strain is applied, most change occurs in $L_A$, while the change in $L_B$ is much less due to
the reason explained above (i.e. large difference of stiffness between Ecoflex and
MWCNT). This optical transmittance value converges to 1 with decreasing slopes by
applying larger strain as shown in Figure S7(b).

Figure 2d and e shows the change of light transmittance of the film by the area of bright
(i.e. optically transparent) regions in the optical microscope image. In Figure 2d, the
black and white regions represent the opaque area covered by the CNTs and the
transparent area due to the microcrack opening. In Figure 2e, the changes of
transparent area and intensity of transmitted light by applying tensile strain are
presented. Two graphs show almost identical relations to the applied strain, which interprets that the increase of the microcrack opening is the dominant principle for the change of the light transmittance of CNT-embedded Ecoflex thin film. The high sensitivity of the sensor could be explained by this microcrack propagation mechanism.

**Figure 2.** Performance characterization of the CNT-embedded Ecoflex thin film based strain sensor: (a) input strain vs. output sensor signal, (b) comparison of the sensor performances of the pristine Ecoflex, CNTs-Ecoflex mixture (CNT concentration = 0.52 wt%), and the proposed CNTs-embedded Ecoflex thin film, (c) loading-unloading
curves of the strain sensor for ε=100-400 % of strains, (d) image analysis of photos of the sensor under strains of ε=0-100 % taken by a CCD camera, (e) comparison of image analysis result (i.e. relative change of bright area) and the sensor response (i.e. relative change of light intensity that transmitted through the sensor) under strains of ε=0-100 %. Here, $A_b$ and $A_{total}$ represent the bright area (with microcrack opening) and total area in Figure 2d. $\Delta I$ and $I_0$ indicate the light intensity change and the light intensity on a zero strain through the sensor.

The dynamic characteristics of the proposed strain sensor is shown in Figure 3. Figure 3a shows the response to various strain inputs from ε=0 % to ε=100 %. The sensors showed good response and recovery characteristics to various strain inputs. Figure 3b compares the sensor responses for different strain rates. The experimental data represents the independence of sensor response to the strain rate in the range of $\frac{d\varepsilon}{dt}=0.01 \text{ s}^{-1} - 1 \text{ s}^{-1}$. For each strain rate, hysteresis was calculated and listed in Table S2. Below the strain rate of 0.2 s$^{-1}$, the hysteresis is under 2 %. Above the strain rate of
0.5 s⁻¹, the motor was overloaded and thus the its vibration caused the error of sensor
response. However, even in this case, the calculated hysteresis is still under 5.5%. Figure
3c shows the durability of the sensor for 13,000 cyclic loading of ε=0-100 %. As shown in
the graph, the initial cyclic loading, the response after 2,000 and 10,000 sets of cyclic
loading, and the response after 13,000 sets of cyclic loading are stable without any
noticeable drift. This suggests that the sensor response can be used without degradation
even if the sensor is repeatedly used for a long time period. The reason of poor stability
of previously reported piezoresistive strain sensors is the loss of electrical connections
due to external strain loading-unloading, as mentioned in the literature. In our proposed
sensor, micro-crack formation is quantified by measuring optical transmittance, and thus
electrical connection loss between the nanomaterials would not affect the performance of
the sensor. In addition, in our sensor, uncured Ecoflex prepolymer permeated through the
CNT network, forming a physical entanglement between CNT and Ecoflex, resulting in a
stable attachment. Although van der Waals bonding exist between the surfaces of CNT
and Ecoflex, mechanical interlocking between them due to complex entanglement
enables their strong physical bonding. The effect of intensity of the light source to the
sensor characteristics is shown in Figure 3d. It can be seen that the sensor response is consistent regardless of the initial light intensity. As explained in the section “Independency of the sensor response to the intensity and wavelength of the light source” of the Supporting Information, the sensor response ($\Delta I/I_0$) depends on the transmittances of pristine Ecoflex ($T_{\text{Ecoflex}}$) and CNT-embedded Ecoflex ($T_{\text{CNT}}$), and the fraction of pristine Ecoflex ($f_{\text{Ecoflex}}$) due to the microcrack opening by the applied strain. As shown in Figure S8, $T_{\text{Ecoflex}}$ and $T_{\text{CNT}}$ are almost constant regardless of the intensity of incident light. Therefore, the sensor response is only dependent on the applied strain, and is not affected by the incident light intensity. The effect of wavelength of the light to the sensor characteristics is shown in Figure S9. In the visible range ($\lambda=460$ nm-620 nm), the sensor characteristic is independent on the wavelength.

The mechanism of the sensor is the transmittance change of the CNT-embedded Ecoflex film due to the opening of microcracks by applied strain. Thus the homogeneity of the microcrack formation in the CNT film is important to achieve the uniformity of the sensing performance, and it was observed by comparing the sensor responses for different
positions of the photocouple (i.e. a pair of light emitting diode (LED) and photodiode(PD)) (see Figure S10). For a 45mm long sample, LED and PD photocouple were positioned at two different locations (x=0 mm and 10 mm with respect to the center). As shown in Figure S10b, there was no significant difference in the sensor performance by changing the sensing locations. This can be explained by the uniform microcrack opening throughout the sensor. As shown in Figure S10c, the relative change of microcrack opening area under applied strain was almost identical for x=0 mm and 10 mm. The numerical simulation result of the strain distribution on the Ecoflex when a bilateral strain was applied along the x-axis reveals that the strain is almost uniform with a maximum error of ±5% in the region of |x|≤15 mm with respect to the center of the sample. (See Figure S10d and e; detail of numerical simulation modeling is provided in the Supporting Information). Therefore, the sensor performances are almost identical at least in the range of |x|≤15 mm.

The reproducibility of the sensor was investigated by measuring the responses of five different samples in the strain range of ε=0-100 %. Spray coated CNT films showed an
average sheet resistance of 78.9 Ω/□ with a standard deviation of 6.31 Ω/□ when no strain was applied (i.e. ε=0 %). As shown in Figure S11a, the sensor responses for five different sensors show good uniformity with a relatively small standard deviation (<10 % of the average) for each strain. It is expected that the standard deviation of the sensor results from the variation of CNT film’s thickness, which is represented by the standard deviation of sheet resistance by 8 %. It is expected that the reproducibility can be further improved by a strict control of the fabrication process.

As shown in Figure S11b and c, the smallest strain that the proposed sensor can measure was determined. In Figure S11b, step strain inputs with an increment of 0.03% were applied to the sensor every 10 sec. The limit of detection can be defined by three times of signal to noise ratio without input signal divided by the slope of starting point of the input and output. For different 6 samples, the limit of detection was calculated using above definition which shown in Table S3, and it turns out to be ε_{LOD}=0.015 %.

Figure S12 shows the transient and steady-state responses of the sensor to a step strain input of ε=100 %. When the strain was maintained at ε=100 % for 10 mins, the drift value
defined as the relative change of response of the sensor was as small as 0.8% of its output response, which reveals high stability of the sensor. Figure S13 shows the determination of the response time of the sensor. Here, the sensor was approximated as a first order system, and the response time could be estimated by the time gap between a ramp strain input and the sensor output. In particular, the time gap when the strain input and sensor response reached 50 %, 63 % and 80 % of the steady-state value was utilized to calculate the response time of the sensor for different applied strain inputs (steady state strains of 10 %, 20 %, 50 %, 100 %). For each strain input, all the response time turned out to be below 50 msec. This result reveals that the sensor has a high response speed and is suitable for many wearable sensing applications that involve quick motions.

Figure S14 shows the harsh environmental effect on the sensor operation. By measuring the sensor response at different relative humidities, we could find that there is no significant influence of relative humidity as shown in Figure S14a. The temperature effect on the sensor performance was investigated by studying the literature on the thermal expansion of Ecoflex 0030 and experimentally measuring its long-term thermal creep.
behavior at an elevated temperature. According to the reference\textsuperscript{29}, thermal expansion coefficient of Ecoflex 0030 is 284.2 ppm/°C. This means that it will elongate by 2.84 % at a temperature increase by 100°C. In common wearable applications, the temperature rise may not be larger than 20°C, thereby the thermal expansion is expected to be less than 0.6 % and will not disturb the sensor response significantly. Although we have considered Ecoflex only for this calculation, the actual sensor sample (i.e. CNT-embedded Ecoflex) is expected to show similar thermal expansion behavior due to very small thickness of CNT layer compared to that of Ecoflex substrate.

In addition, long-term thermal creep characteristics of Ecoflex 0030 was examined under constant loads of 1.96 N and 0.49 N at T=100 °C and 50 °C for a long time period (Figure S14b and c). When the temperature increased from the room temperature to high temperature (T=100 °C), strain was quickly reduced as shown in Figure S14b. Under load =1.96 N at T=100 °C, the strain decreased from $\varepsilon=108$ % to $\varepsilon=90$ %. When a load of 0.49 N was applied at T=100 °C, the strain decreased from $\varepsilon=41$ % to $\varepsilon=32.7$ %. It is presumed that the heating caused the volume shrinkage of Ecoflex by evaporating the water.
molecules that were adsorbed on the Ecoflex. (This is explained below with the result of Figure S14d) After this initial strain shrinkage, slow but gradual strain increase is observed for a long time period due to the creep behavior of Ecoflex. This creep is more obvious when larger loading is applied at higher temperature (eg. 1.96 N at 100 °C) than when smaller loading is applied at lower temperature (eg. 0.49 N at 50 °C). The DSC characteristics for two heating cycles in Figure S14d reveals that the glass transition did not occur in the temperature range of 20-200 °C. Instead, the difference between the 1st and 2nd heating processes reflects that the water evaporation occurred from Ecoflex during the 1st heating step. Figure S14e shows the thermal decomposition temperature of the Ecoflex 0030 starting above 200 °C. Therefore, in normal working conditions within moderate temperature ranges, thermal decomposition of Ecoflex will not be an issue. In summary, there would be a temperature effect to the sensor at high temperatures (i.e. initial volume shrinkage due to the water evaporation, followed by a long-term creep deformation). However, for common wearable applications, this high temperature environment would rarely occur. Therefore, the temperature effect may not be significant for most operation conditions.
Figure 3. Dynamic characteristics of the CNT-embedded Ecoflex thin film based strain sensor: (a) sensor response to various input strains between $\varepsilon=0$ and $\varepsilon=100\%$, (b) Sensor response to the different input strain rates (strain rate= 0.01 s$^{-1}$, 0.05 s$^{-1}$, 0.1 s$^{-1}$, 0.2 s$^{-1}$, 0.5 s$^{-1}$, 1 s$^{-1}$), (c) Stability of the sensor after 2000, 10000, and 13000 cycles, (d) Responsiveness of the sensor to different input strains and light intensity.
0.2 s⁻¹, 0.5 s⁻¹ and 1 s⁻¹), (c) durability test for 13,000 cycles of ε=0-100 %, (d) effect of initial light intensity on the sensor response; The response of the sensor is independent to the initial light intensity from the light source.

Our sensor exhibits a wide dynamic range (0-400%), high sensitivity (GF~30), and good stability during long term cyclic loading as shown in Table S4. The capacitive strain sensor has a low sensitivity (GF<1) because its main mechanism is the geometric change as explained above.²²,³⁴ As compared to the capacitive sensor, piezoresistive strain sensor exhibits higher sensitivity and linearity, but suffer from poor long term stability under repeated loading.¹⁵ In Zhang, et al.’s work, vertically aligned CNT – Ecoflex composite based piezoresistive strain sensor exhibited reduced drifting, but the linearity was low and GF was less than 10.²⁶ Recently, researchers have reported other strain sensors that exploited 3D structured or 2D patterned composite films with silver nanowires or graphene as conductive nanomaterials.³⁵–³⁸ In their work, localized microcrack formation within 3D structures or 2D patterns significantly increased the
sensitivity of the sensor, but they still suffered from long-term drift. Optical type strain
sensor based on the TiO$_2$ showed a low sensitivity (GF~3) and its long-term stability
was not specified in Zhai, et al.'s work.$^{27}$ In contrast, the our proposed sensor has a
high GF of 31 for $\varepsilon=100\%$, high linearity ($R^2=0.98$), and superior long-term stability for
the strain range of $\varepsilon=0-100\%$.

In order to demonstrate the applicability of our sensor to practical wearable strain-
sensing devices, it was employed as (i) human motion detecting device that measures
the finger bending angle for the robot arm control, (ii) human posture monitoring device
to detect the neck posture, and (iii) subtle human motion monitoring device to detect
human neck pulse, saliva swallowing, and face motion. We demonstrated a human
motion detection device by combining the CNT-embedded Ecoflex thin film and a LED-
PD photocouple (Figure 4a). In this strain sensor package, the light emitted from the
LED transmits through the CNT-embedded Ecoflex thin film and is detected by the PD
underneath. The light transmission through the CNT-embedded Ecoflex thin film is
changed by the applied strain and can be quantified by the PD measurement. The
details of the fabrication process and experimental setup are described in the experimental section. The strain-response measurement was performed using the human motion detection system (Figure 4b), and it was observed that the sensor shows a high gauge factor (GF~59) for the uniaxial stretching. It should be noted that many human motions are not just uniaxial stretching, but include bending motions. As presented in Figure 4c, the sensor response exponentially increased to the increasing bending angle. To demonstrate the real human motion detection capability, the sensor was integrated on a human finger for detecting the finger bending motion (Figure 4d and Movie S1). In this graph, it can be observed that the sensor can detect finger bending motions with good repeatability, stability and quick response. Moreover, our sensor was utilized for the control of a robot arm with two degrees of freedom (2-DOF) – a gripper and a wrist. The human finger bending motion was measured to move the gripper while the wrist bending motion was utilized to move the wrist of the robot arm. As shown in Figure 4e and Movie S2, the bending motions of the finger and wrist were independently transmitted to the robot arm in real time.
**Figure 4.** Applications of the CNT-embedded Ecoflex thin film based strain sensor with photocoupler consisting of an LED chip and a photodetector for the human motion detection: (a) schematic image and photo of the strain sensor package, (b) response of strain sensor package to the uniaxial strain input, which shows a high gauge factor of 70 in the strain range of $\varepsilon=0-50\%$, (c) response of the strain sensor package to the bending angle, (d) detection of finger bending motions, (e) real-time control of robot gripper and wrist by monitoring the motions of human finger and wrist.
As further wearable sensing applications of our sensor, the posture detection of the neck was carried out. As illustrated in Figure 5a and b, a neck posture sensor module was composed of multiaxial strain sensor array with an angle of 15° between each sensor (sensor #1, 2, and 3 from left to right) and were attached on the backside of the neck. Each sensor showed different output signal by the neck motions. It was observed that the responses increased coincidentally for all three sensors when the backside of the neck extended by forward bending of the neck. When the neck was turned to the left side, the responses of the sensors #2 and #3 increased because tensile strains were applied on them, while the response of the sensor #1 decreased since it was subjected to a compressive loading. As expected, right turning motion of the neck made opposite consequence. These results show that our sensors could be utilized as a neck posture monitoring device. Currently, the disk disorder is the uprising problems of the modern people, which is caused by the wrong position during their working time. Our proposed sensor could be a promising solution to prevent this problem by continuous neck posture monitoring.
Figure 5. Applications of the CNT-embedded Ecoflex thin film based strain sensor for the human neck posture monitoring with an array of three strain sensor packages: (a) schematic image and photo of array of three strain sensor packages (CNT-embedded Ecoflex thin film, LED and photodetector for each sensor package) with an angle of -15°, 0, and +15° with respect to the cervical vertebral for each package, (b-c) real-time monitoring of neck posture that can recognize the neck extension (i.e. front bending), left turn, and right turn with 3-axial strain sensor array.

In addition to the large motion detection explained above, the detection of small motions such as human neck pulse, uvula motion during saliva swallowing, and face motion
during speaking or expression can be realized using our sensor. The uniaxial strain sensor was attached on the anterior triangle of the neck where the carotid artery is located (see Figure 6a). The real-time measurement of the carotid pulse was carried out using the sensor (~70 pulse/min) as shown in Figure 6a. Swallowing motion of the uvula was monitored by our sensor attached on the uvula (Figure 6b). In addition, our sensor was capable to detect the face muscle motion during the speaking and emotional face expression change such as speaking, smiling, and crying that lead to the subtle strain of the skin. Face strain detection when speaking “hello”, “yellow”, and “red” was carried out, and the result indicated that the sensor could distinguish different face motions by speaking (Figure 6c). When speaking “hello” or “yellow”, the sensor showed an increasing response due to the tensile strain applied on the bottom side of orbicularis oris muscle (i.e. muscle between lips and jaw). When speaking “red”, there was an undershoot of the sensor response due to the initial pulsing motion of the lip for pronouncing the “re” sound that applied a compressive strain to the bottom side of orbicularis oris muscle. Similarly, the strain change of the skin below the lips during smiling and crying motions could be detected by our sensor (Figure 6d and e).
summary, our proposed sensor can be applied to the real-time monitoring of various
human motions with both subtle strains (neck pulse and face motion) and large strains
(neck, finger, and wrist motions).

Figure 6. Applications of the CNT-embedded Ecoflex thin film based strain sensor to the
monitoring of subtle human motions such as (a) neck carotid pulses, (b) swallowing
motion on the uvula, (c) human face expression during speaking different words (“hello”,
“yellow”, and “red”), (d) smiling, and (e) crying.
CONCLUSION

In summary, we developed a novel optical type strain sensor based on the transmittance change of CNTs-embedded Ecoflex thin film. Tensile strain caused the generation and propagation of microcracks on CNT network, resulting in the increase of optical transmittance, which was detected by the photodetector positioned below the CNT-embedded Ecoflex thin film. Our strain sensor shows a wide dynamic range (ε=0-400 %), high sensitivity (GF~30), small hysteresis (1.8% for ε=0-100 %), and good stability during long term cyclic loading (drift < 2 % for 13,000 cycles of repeated strain of ε=0-100 %). As compared with the piezoresistive strain sensors, our sensor showed significantly lower hysteresis and higher stability. The sensor has been applied to various wearable human motion monitoring applications such as the detection of finger/wrist bending motions, neck posture, neck pulse, swallowing, and face motion. It is foreseen that our sensor can be broadly applied to the human motion monitoring with a wide range of strain. Furthermore, we believe that the proposed sensor has a great potential for the wearable electronic systems, electronic skins, soft robots, and human-
machine interface systems due to its high linearity, quick response, small hysteresis, and superior long-term stability.

ASSOCIATED CONTENT

Supporting Information. The following files are available free of charge via the internet at http://pubs.acs.org.

Sensitivity tuning factor analysis; Independency of the sensor response to the intensity of the light source; Additional sensor characteristics; Comparison of the performances of the sensor with other nanofiller-based strain sensors; Details of fabrication process, experimental setup and image analysis process; Table S1-S4 and Figure S1-S14 (PDF)

Real-time monitoring of finger being using the CNT-embedded thin film based strain sensor (AVI)

Control of robot motions using a real-time monitoring of human finger and wrist motions (AVI)
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Strain sensor based on the optical transmittance change of the CNT-embedded Ecoflex thin film for wearable human motion system was developed. CNT-embedded Ecoflex changes its optical transmittance by the microcrack propagation by the applied tensile strain. The sensor has high sensitivity (GF~30), small hysteresis (<1.8%), wide dynamic range (~400%), and superior long-term stability. The sensor was applied to various human motion detection applications.